

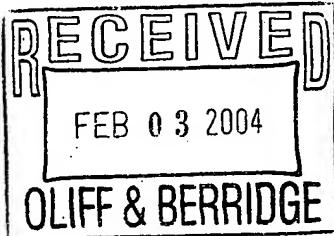


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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/686,634	10/17/2003	2811	1280	104741.01	24	34	6

25944
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CONFIRMATION NO. 8919

FILING RECEIPT



OC000000011802091

Date Mailed: 02/02/2004

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Applicant(s)

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Assignment For Published Patent Application

Seiko Epson Corporation, Tokyo, JAPAN;

Domestic Priority data as claimed by applicant

This application is a CON of 09/423,969 11/17/1999 ABN
which is a 371 of PCT/JP99/01327 03/17/1999

Foreign Applications

JAPAN 10-67508 03/17/1998
JAPAN 11-32123 02/10/1996

1999

Projected Publication Date: To Be Determined - pending completion of Security Review

Non-Publication Request: No

Early Publication Request: No



Title

Method of forming thin film patterning substrate including formation of banks

Preliminary Class

257

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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Sunichi SEKI et al.

Application No.: 10/686,634

Docket No.: 104741.01

Filed: October 17, 2003

For: METHOD OF FORMING THIN FILM PATTERNING SUBSTRATE INCLUDING
FORMATION OF BANKS

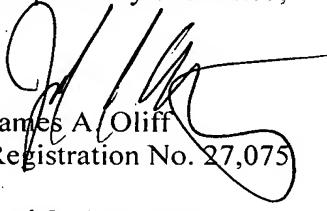
REQUEST FOR CORRECTION OF PALM RECORDS

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Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,


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Date: February 10, 2004

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